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CONFIRMATION NO. 5477

<b>SERIAL NUMBER</b> 10/519,152	<b>FILING OR 371(c) DATE</b> 08/10/2005 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> PHCF-03037US
<b>APPLICANTS</b> Masatomo Shibata, Tokyo, JAPAN; Yuichi Oshima, Tokyo, JAPAN; Takeshi Eri, Tokyo, JAPAN; Akira Usui, Tokyo, JAPAN; Haruo Sunagawa, Tokyo, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/08173 06/26/2003				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-190270 06/28/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 4	<b>TOTAL CLAIMS</b> 17
<b>INDEPENDENT CLAIMS</b> 6				
<b>ADDRESS</b> 21254				
<b>TITLE</b> Porous substrate and its manufacturing method, and gan semiconductor multilayer substrate and its manufacturing method				
<b>FILING FEE RECEIVED</b> 1630	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	